

RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2811

PATENT APPLICATION  
Docket No.: 4591-227  
Client Ref. No.: IE10176-US-1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Do-Hyung KIM, et al.

Serial No.: 10/083,756 Examiner: Hu, Shouxiong

Filed: February 25, 2002 Group Art Unit: 2811

Confirmation No.: 2262

For: METHOD FOR FORMING LAYER FOR TRENCH ISOLATION  
STRUCTURE

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116**

Responsive to the Final Office Action, Paper No. 20070716, dated July 26, 2007, please amend the application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.